RABIN & BERDO, P.C.

Specializing in Patent, Trademark And Copyright Law

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September 9, 2003

730033 U.S PTO 10657207



In Affiliation with Weiss, Moy & Harris, PC having offices in Arizona and Nevada, and in Washington, DC with Rabin & Berdo, PC

Mail Stop: PATENT APPLICATION

P.O. Box 1450

Alexandria, VA 22313-1450

Attorney Reference: FUJI 136

New Patent Application of: Hiroomi TSUTAE

Title: PROCESS OF CLEANING A SEMICONDUCTOR MANUFACTURING SYSTEM

AND METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

Sir:

Please find attached hereto an application for patent that includes:

Specification, Claims and Abstract (27 Pages)

2 Sheets of Formal Drawings (Fig. 1 through Fig. 2) [x]

Inventor's Declaration and Power of Attorney (3 Pages) [x]

Assignment document with cover page (2 Pages) [x]

Information Disclosure Statement, Form PTO-1449, and copies of three references [x]

Preliminary Amendment (6 Pages) [x]

Claim for priority and Priority document [x]

Fee (see formula below) [x]

Form PTO-2038 [x]

Basic Fee \$750/375 Additional Fees:

Total number of claims: 19

in excess of 20: 0 times \$18/9

Number of independent claims: __5_

in excess of 3: 2 times \$84/42

Multiple Dependent Claims \$280/140

Recording Fee \$40.

\$ 750.00

\$ _168.00

\$ 0.00

\$ 0.00

\$ 40.00

TOTAL FEES FOR THE ABOVE APPLICATION

\$ <u>958.00</u>

In the event there is attached hereto no check or form PTO-2038 (credit card payment form), or a check or form for an insufficient amount, please charge the fee to our Account No. 18-0002 and notify us accordingly.

The right of priority is claimed under 35 USC §119 of Japanese Application No. 2003-008305, filed January 16 2003.

Respectfully submitted,

September 9, 2003

Date SMR:tl Steven M. Rabin (Reg. No. 29,102)

Customer No. 23995

FEE ENCLOSED:\$
Please charge any fee to our Deposit Account